IFW



PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/625,546

Confirmation No.: 8197

In re Application of:

Yutaka HIROSE et al.

Group Art Unit: 2811

Filed: July 24, 2003

Examiner: Nitin Parekh

For: CONTACT FORMATION METHOD

AND SEMICONDUCTOR DEVICE

## **AMENDMENT**

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed August 4, 2004, please amend the above-identified application as follows: